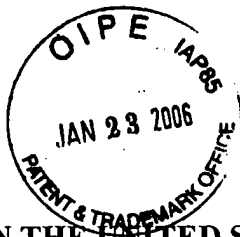


SEPP21.001C1



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Tois et al.
Appl. No. : 10/678,766
Filed : October 2, 2003
For : METHOD OF GROWING OXIDE
THIN FILMS
Examiner : Matthew J. Song
Group Art Unit : 1722

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

January 19, 2006

(Date)

Andrew N. Merickel, Reg. No. 53,317

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted with a Request for Continued Examination and is responsive to the Final Office Action mailed on July 20, 2005

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.